

PATENT  
ATTORNEY DOCKET: 46884-5345

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Satoshi MATSUMOTO et al. ) Confirmation No.: 8192  
Application No.: 10/518,392 ) Group Art Unit: 2855  
Filed: July 25, 2005 ) Examiner: Gail K. Verbitsky  
For: LASER PROCESSING APPARATUS,)  
LASER PROCESSING )  
TEMPERATURE MEASURING )  
APPARATUS, LASER )  
PROCESSING METHOD, AND )  
LASER PROCESSING )  
TEMPERATURE MEASURING )  
METHOD )

Commissioner for Patents  
U.S. Patent and Trademark Office  
**Customer Window, Mail Stop Amendment**  
Alexandria, VA 22314

Sir:

**AMENDMENT**

In response to the Office Action dated February 24, 2009, the period for response to which runs through May 26, 2009 (May 24, 2009 being a Sunday and May 25, 2009 being a Federal Holiday), please amend the above-identified application as follows.